

What Can We Learn From Proton Recoils about Heavy-Ion SEE Sensitivity?

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Abbreviations

CMOS—Complementary Metal Oxide Semiconductor

COTS—Commercial Off The Shelf

DUT—Device Under Test

E—Energy

E_{dep}—Energy Deposited

FPGA—Field Programmable Gate Array

GCR—Galactic Cosmic Rays

- GEDI—Global Ecosystem Dynamics Investigation (a Lidar instrument set to fly on the ISS)
- ISS—International Space Station
- LEO—Low-Earth Orbit
- LET—Linear Energy Transfer
- LET_{EQ}—Equivalent Linear Energy Transfer

LET₀—Onset LET

- MOSFET—Metal-Oxide Semiconductor Field Effect Transistor
- SEB—Single-Event Burnout

SEE—Single-Event Effects

SEGR—Single-Event Gate Rupture

- SEL—Single-Event Latchup
- SEU—Single Event Upset

Si-silicon

SOTA—State-Of-The-Art

SV—Sensitive Volume

TID—Total Ionizing Dose

TNS—Transactions on Nuclear Science

WC—Worst Case

- Z—Atomic number of an element
- \forall —"For all"
- α particle—two protons and two neutrons bound together into a particle identical to a helium nucleus
- $\sigma\text{-}Cross~Section$
- $\sigma_{\scriptscriptstyle sat}\text{--}Saturated$ Cross Section
- θ —Angle



SEE Testing: Protons or Heavy lons?



- Heavy-ion SEE testing poses well known difficulties:
 - Expensive in terms of cost and schedule
 - Often requires extensive modification of part to ensure beam reaches device sensitive volumes
 - Mainly geared to testing components rather than systems
- Protons potentially offer relief from many of these issues

Physics of Proton-Si Recoils



- Protons cause SEE via indirect ionization
 - Recoil ion from p-Si collision provides ionization for SEE
 - Proton accelerates and excites the ion, which then de-excites, emitting nuclear fragments n, p and α) \rightarrow 3 \leq Z_{RFC} \leq 15
 - Recoil ions have low energy/short range, $3 \le Z_{REC} \le 15$ and are emitted over a range of angles
 - Evaporation particles ($\boldsymbol{\alpha}$ particles) may be important for very sensitive devices



Why 200 MeV protons?







Proton Fluence: How Much is Enough?

- SEE test goal
 - Realize representative sample of error modes that might realistically occur
 - SEE are Poisson; so they can occur any time, even if they are low probability
- JESD-57 goal of establishing "...with high statistical confidence that all sensitive volume on the DUT have been irradiated..." likely not feasible for current parts
 - Finite fluence + small feature sizes mean some features will be missed
 - How repetitive is device architecture?
 - Complicated devices (e.g., FPGAs, Processors, etc.) need higher fluence than simple ones (e.g., simple memory, logic...)



What Proton Fluence is Enough?

Infrared micrograph of a portion of a 512 Mb SDRAM ~60×70 μm^2

- Shows both memory cells and control logic (10 yr. old tech.) Red spots are ion hits

10¹⁰ 200 MeV protons/cm²



20% of areas this size get 0 hits for $10^{10}\,\text{cm}^{-2}$

10¹¹ 200 MeV protons/cm²





10¹² 200 MeV protons/cm²



Coverage from 10⁷ heavy ions/cm²

What About More Recent Technologies?

Intel I7 Processor (2008)

| Process Size: | 45 nm |
|---------------|-------------|
| Transistors: | 731 million |
| Die Size: | 263 mm² |





- For 10¹⁰ 200-MeV protons/cm²
 - Average area per ion (~2890 μm²) contains about 7800 transistors
 - For comparison, an Intel 8080 8-bit processor had ~6000 transistors.
 - 10% chance no ions strike an area >70000 μm²) containing >90000 transistors (half way between an Intel 80186 and 80286 (16-bit))
- For 10¹² 200-MeV protons/cm²
 - Average area per ion contains 80 transistors
 - 10% chance of missing area w/ 1250 transistors
- Heavy-ion test run (10⁷ ions/cm²)
 - Transistor counts in 10 μm^2 are 28.9 and 460
- But!
 - Recoil Ions not all created equal
 - Produced w/ range of Z, energy, LET and angle

Recoil Ion Fluence Falls Rapidly If We Require Greater Range





Dealing with Range Limitation

- LET dependence is an approximation
 - SEE susceptibility depends on charge collected in the sensitive volume
 - For recoil ions in deep SV, charge deposited limited by range, not LET
- Introduce equivalent LET, LET_{EQ}

 $LET_{EQ} = \frac{E_{dep}}{(\rho \times z)}$

- E_{dep} is energy deposited in SV by ion
- ρ is density of Si, z is SV depth
- LET_{EQ} is the ion's average LET if it reaches the bottom of the SV
- LET_{EQ} is the constant LET an ion would need to deposit E_{dep} in SV assuming normal incidence









- Even for shallow SV, low-LET ions are less likely to cause an SEU
 - Can derate fluence at each LET/LET_{EQ} by Weibull factor
 - $Weibull(LET_{EQ} LET_0, W, s)$
 - Results in an equivalent fluence
 - Can be used to find worst-case rate for a null result at a given confidence level.
- Matra 256 K SRAM has limiting cross section of 0.2 cm²
- Predict ~131 upsets with 10¹⁰ 200-MeV protons
 - Limiting cross section measured by B. Doucin ('95 RADECS) ~2x10⁻⁸ cm²/dev (within a factor of 2)





Effect of Cross Section vs. LET Shape

- Inferring proton susceptibility from heavy-ion data is straightforward
 - Use σ vs. LET and recoil ion spectrum to estimate expected events ${<}N{>}$
- Constrain rate w/ proton data
 - Recoil fluences + LET₀, s and W set relative contributions
 - Choose σ_{sat} so probability of seeing no events>10% \rightarrow <N>=2.3
 - Highest rate bounds null result in proton test at the 90% confidence level

| WC Rate | <n>@1cm2</n> | Per bit cs | S | W | LET0 |
|----------|--------------|------------|-----|----|------|
| 0.000856 | 32226.38947 | 1.19E-07 | 0.5 | 5 | 0.5 |
| 0.000159 | 18577.27893 | 1.28E-08 | 0.5 | 5 | 1.5 |
| 6.17E-05 | 12970.74197 | 3.47E-09 | 0.5 | 5 | 2.5 |
| 4.5E-05 | 8703.467731 | 1.7E-09 | 0.5 | 5 | 3.5 |
| 3.75E-05 | 6097.639989 | 9.91E-10 | 0.5 | 5 | 4.5 |
| 0.000818 | 24892.46517 | 8.82E-08 | 0.5 | 10 | 0.5 |
| 0.000153 | 14486.82459 | 9.57E-09 | 0.5 | 10 | 1.5 |
| 6.09E-05 | 10092.54183 | 2.66E-09 | 0.5 | 10 | 2.5 |
| 4.47E-05 | 6765.500655 | 1.31E-09 | 0.5 | 10 | 3.5 |
| 3.75E-05 | 4714.079379 | 7.64E-10 | 0.5 | 10 | 4.5 |









GCR w/ 0.5<LET<2 MeV-cm²/mg • 3<Z<15—produce LET from 0.0008 2-12 MeV-cm²/mg

0.0009

• Z=2 due to evaporation process \rightarrow mainly 0.5<LET<2

• Recoil fluence vs. LET due to

nuclear physics

- lons w/ 0.5<LET<2 ~1.6x more than w/ 2<LET<12
- For GCR @ ISS ~30x more ions w/ 0.5<LET<2 than from 2<LET<12
- More SOTA COTS have onset LET<2 MeV-cm²/mg
 - Proton test method may be less effective for latest generation parts



How High Can the SEE Rate Be if We Didn't See It in the Test? Select σ so >10% chance of seeing 0 events w/ 10¹⁰ 200-MeV p/cm² test.

(SEE/day) 0.0007 Rate high because few proton recoils make discovery unlikely even if σ high Possible Rate 0.0005 0.0004 0.0003 0.0002 0.0001 0 Onset LET (MeVcm²/mg)

Rate high due to lots of

How Do We Better Bound Heavy-Ion SEE w/ Proton Testing?



- First, don't try to make protons do what they cannot do well
 - If SEGR/SEB are probable concerns, recommend a go/no-go heavy-ion test
 - WC voltages, single ion w/ predetermined LET, Z and range
 - For SEL in bulk CMOS where depth of SV likely >5-10 μ m, recommend go/no-go heavy-ion test
 - Especially if many copies of same part used in design
 - WC temperature, bias, single-ion w/ predetermined LET, range.
 - May also be inappropriate for studying multi-bit upsets and upsets in technologies with deep SV (e.g. SiGe)
- Increase proton fluence
 - Ensures errors/failures observed during test more likely to resemble those seen on orbit
 - Reduces bounds on rates for "unknown SEE modes"
 - True for both high LET_0 and low LET_0
 - If dose is too high, can test multiple copies of device/board/box
 - High-energy neutron testing may also be an option
- Proton SEE data must be analyzed conservatively
 - Using LET_{EQ} of recoils reduces chances of underestimating SEE sensitivity
 - LET_{EQ} better reflects physics of SEE modes and reduces to LET if SV for SEE mode is thin
 - Understanding device technologies can improve bounds on SEE rates achievable by proton testing